

RECEIVED
CENTRAL FAX CENTER

JUN 30 2006

ASMEX.433A

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| | | |
|------------------|---|---|
| Applicant | : | Matthew G. Goodman, <i>et al.</i> |
| Application No. | : | 10/775,522 |
| Filed | : | February 10, 2004 |
| For | : | TWO-STAGE LOAD FOR PROCESSING BOTH SIDES OF A WAFER |
| Examiner | : | Sylvia MacArthur |
| Group Art Unit | : | 1763 |
| Confirmation No. | : | 1057 |

AMENDMENT UNDER 37 C.F.R. 1.114

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This paper is responsive to an Office Action mailed March 31, 2006. A response filed by June 30, 2006 falls within the three-month shortened statutory period.

Amendments to the Claims are reflected in a listing of claims beginning on page 2 of this paper.

Remarks begin on page 6 of this paper.